JC17 Rec'd PCT/PTO 05 MAY 2005

APPLICATION INFORMATION

Application Type::

REGULAR

Subject Matter::

UTILITY

CD-ROM or CD-R?::

NONE

Title::

METHOD OF FORMING FILM ON

SUBSTRATE

Attorney Docket Number::

271672US2PCT

Total Drawing Sheets::

6

INVENTOR INFORMATION

Applicant Authority Type::

INVENTOR

Primary Citizenship Country::

Japan

Status::

FULL CAPACITY

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CORRESPONDENCE INFORMATION

Correspondence Customer Number::

22850

REPRESENTATIVE INFORMATION

Representative Customer Number::

22850

DOMESTIC PRIORITY INFORMATION

Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application	National Stage of	PCT/JP03/14188	11/07/03

FOREIGN PRIORITY INFORMATION

Application Number:	Country::	Filing Date::	Priority Claimed::
2002-325000	Japan	11/08/02	YES

ASSIGNMENT INFORMATION

. 10/533810 JC17 Rec'd PCT/PTO 05 MAY 2005

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